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| FORM PTO-1449<br>Page 1 of 1  | Atty. Docket No.:<br>H0004490(1100.1226101) | Serial No.:<br>10/750,580 |
| LIST OF PATENTS AND PUBLICATIONS FOR<br>APPLICANT'S INFORMATION<br>DISCLOSURE STATEMENT | Applicant: Robert E. Higashi et al.         |                           |
|   | Filing Date:<br>December 29, 2003           | Group Art:<br>unknown     |
|   |   |                           |

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| EXAMINER: <i>[Signature]</i> | DATE CONSIDERED: 12/02/2005   |

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.